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APPLICANTS

Eric R. Blomiley, Boise, ID;
 Nirmal Ramaswamy, Boise, ID;
 Ross S. Dando, Nampa, ID;
 Joel A. Drewes, Boise, ID;
 Alan B. Colwell, Boise, ID;
 Eduardo A. Tovar, Caldwell, ID;

** CONTINUING DATA *****

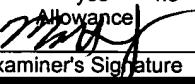
none JM

** FOREIGN APPLICATIONS *****

none JM

IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

06/22/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY ID	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		12	49	6
Verified and Acknowledged	 Examiner's Signature  Initials				

ADDRESS

021567

TITLE

Deposition apparatuses, methods of assessing the temperature of semiconductor wafer substrates within deposition apparatuses, and methods for deposition of epitaxial semiconductive material

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